



Appl. No. 09/602,395

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. ....09/602,395  
Filing Date ..... June 22, 2000  
Inventor..... John T. Moore  
Assignee..... Micron Technology, Inc.  
Group Art Unit.....2813  
Examiner ..... Pham, Thanhha S.  
Attorney's Docket No. ....MI22-1384  
Title: Methods of Forming Oxide Regions Over Semiconductor Substrates

**RESPONSE TO DECEMBER 4, 2003 FINAL OFFICE ACTION**  
**TO ACCOMPANY RCE FILING**

To: Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

From: Jennifer J. Taylor, Ph.D. (Tel. 509-624-4276; Fax 509-838-3424)  
Wells St. John P.S.  
601 W. First Avenue, Suite 1300  
Spokane, WA 99201-3828

RECEIVED  
MAR 12 2004  
TECHNOLOGY CENTER 2800

**AMENDMENTS**

**Introductory Comments**

In response to the Office Action dated December 4, 2003, applicant amends and remarks as follows.